



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: MARUYAMA, Kenji, et al.

Entered w/ RCE  
dtd 4/4/08

Serial No.: 10/532,249

Group Art Unit: 2891

Filed: April 22, 2005

Examiner: FULK, Steven J.

DMK

4/21/08

P.T.O. Confirmation No.: 1069

For: METHOD OF PRODUCING SEMICONDUCTOR DEVICE

**AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**

**MAILSTOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 4, 2008

Sir:

In response to the Office Action dated January 8, 2008, please amend the above-identified application as follows. A Request for Continued Examination (RCE) is concurrently filed herewith.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.